

Ultra-smooth and high efficiency alkali antimonide photocathodes for future light sources

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Introduction:

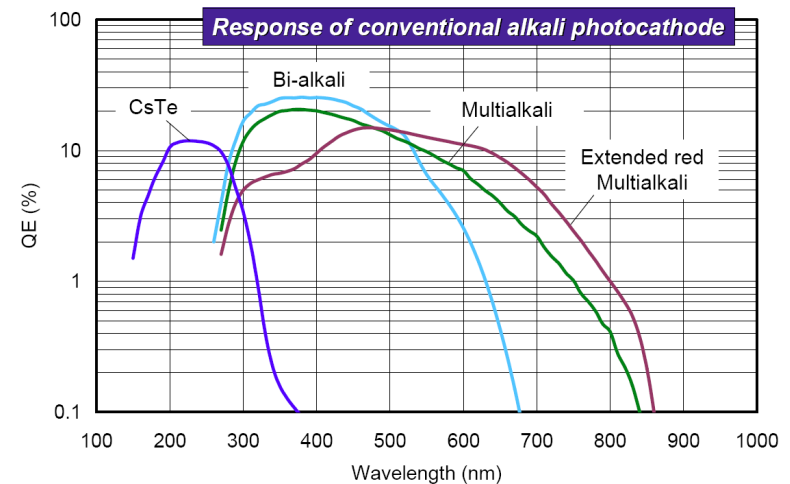
K-Cs-Sb photocathode as electron source

Advantages:

- ☐ High QE
- ☐ Low emittance
- ☐ Fast response time in visible light
- ☐ APEX
- ☐ BNL

Improvement:

- Higher QE @ 532 nm
- Smoother surface
- Larger scale?

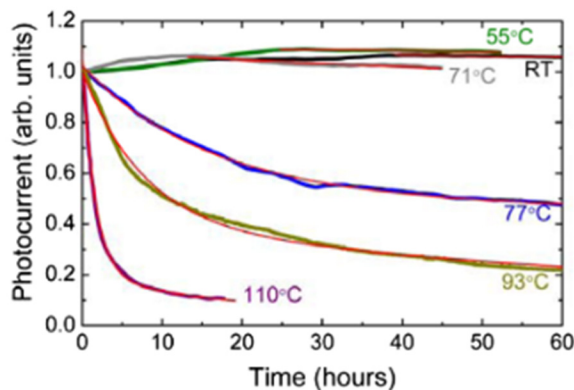


Introduction:

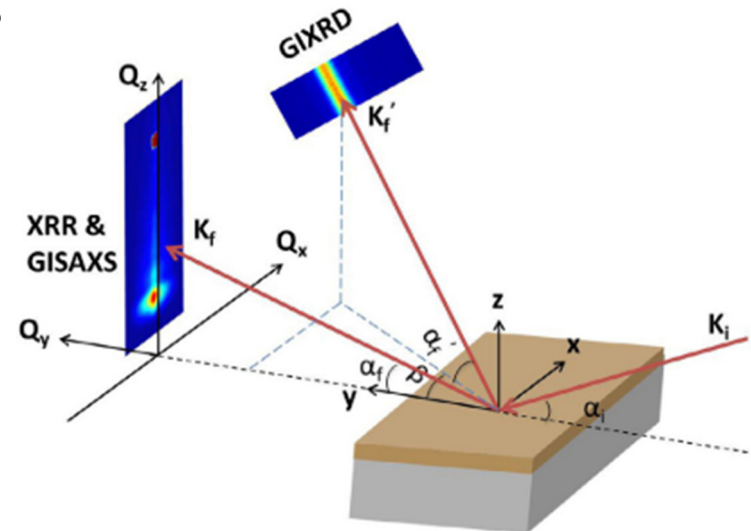
Efforts in characterization of KCsSb photocathode

How to make a good K-Cs-Sb photocathode?

- Temperature?
- K, Cs, Sb ratios?
- Surface roughness?
- Thickness, *etc.*?



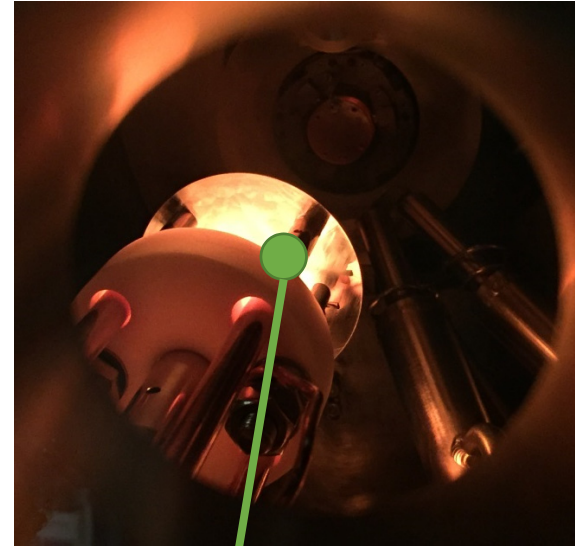
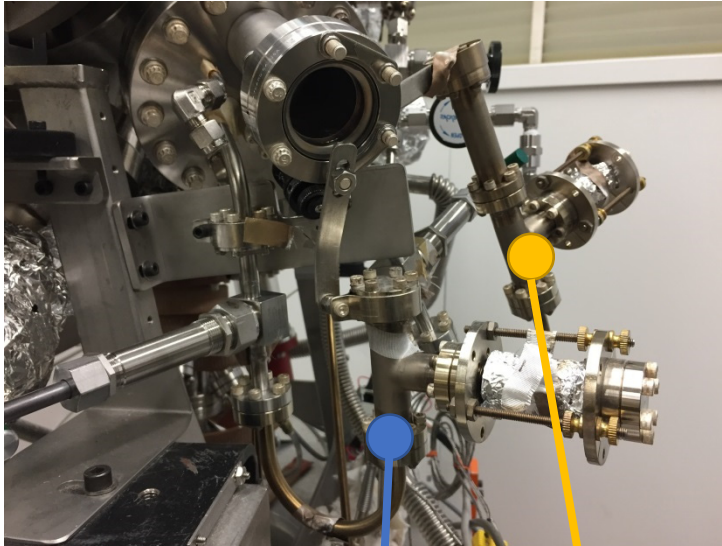
- ❑ Decay curves of K-Cs-Sb at different temperatures



- ❑ *in situ* real time x-ray measurement setup on K-Cs-Sb

Z. Ding, *et al.*, *Phys. Rev. Accel. Beams.*, **2017**, 20, 113401.
J. Xie, *et al.*, *J. Phys. D: Appl. Phys.*, **2017**, 50, 205303.

Experimental Setup: Cathode Growth with Effusion Cell



- ❑ Effusion cell → high capacity, large deposition area
- ❑ **Sequential** or **Co-dep**

Experimental setup: *Operando* chamber

Grow controls:

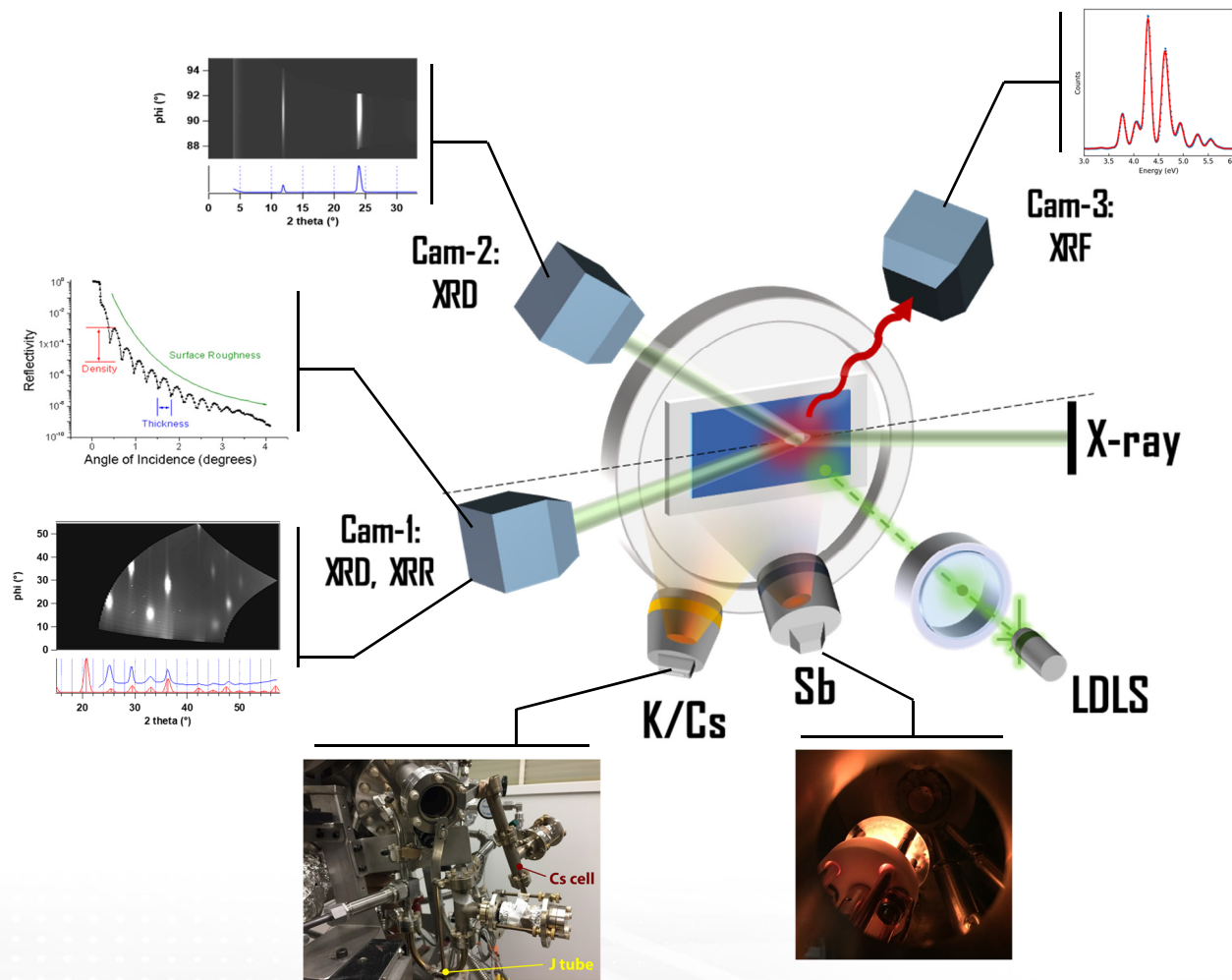
- ☐ T_{sub}
- ☐ Flux rate

Characterization:

- ☐ QCM
- ☐ XRD
- ☐ XRR
- ☐ XRF
- ☐ QE

Upcoming:

- ☐ Photoconductivity
- ☐ RHEED



K-Cs-Sb preparation: Ternary co-deposition vs. Two-step

Ternary Co-deposition



Cs, K, Sb
Co-deposition @ 90°C

Two-step Evaporation

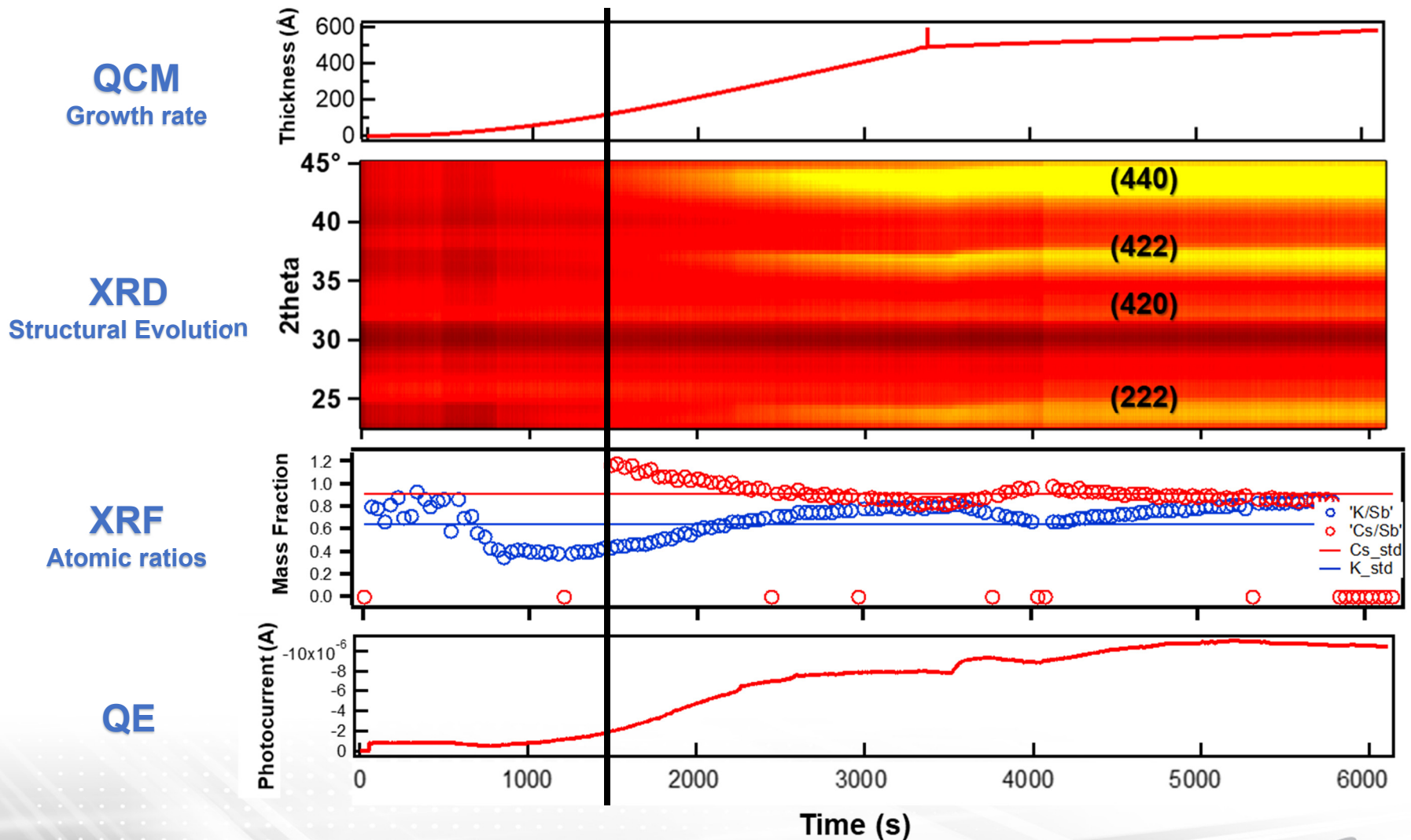


K, Sb co-deposition @ 120°C to
maximize QE @ 380 nm

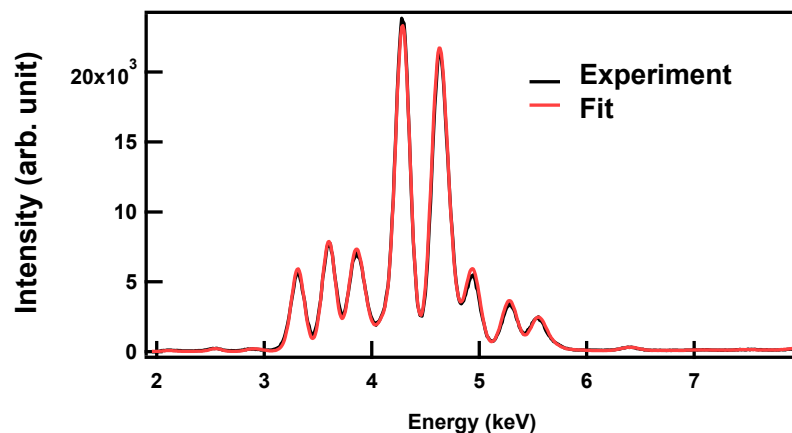


Cs deposition @ 100°C to
maximize QE @ 100°C

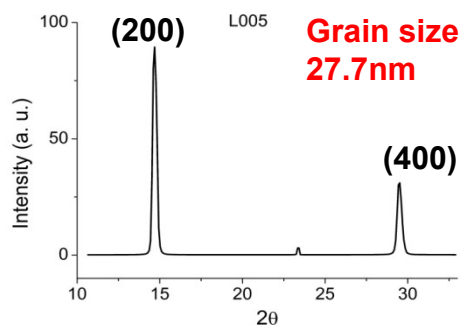
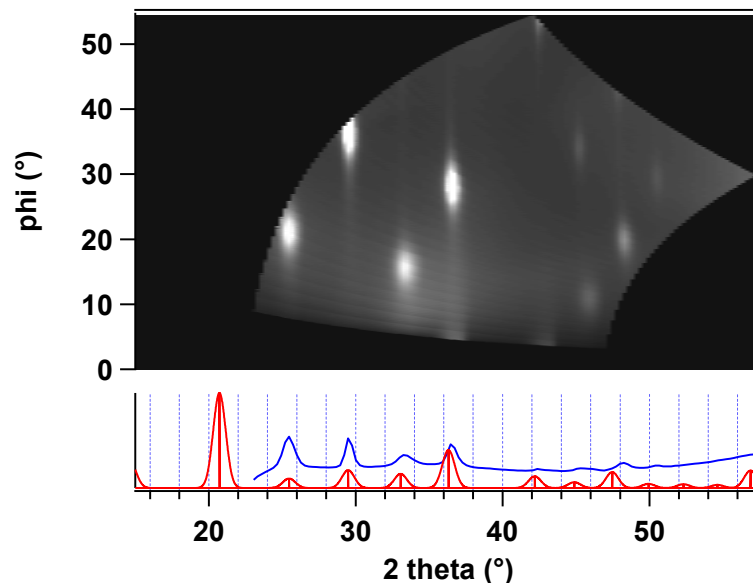
TC Method: *in-situ* monitoring



TC Method: sample analyses

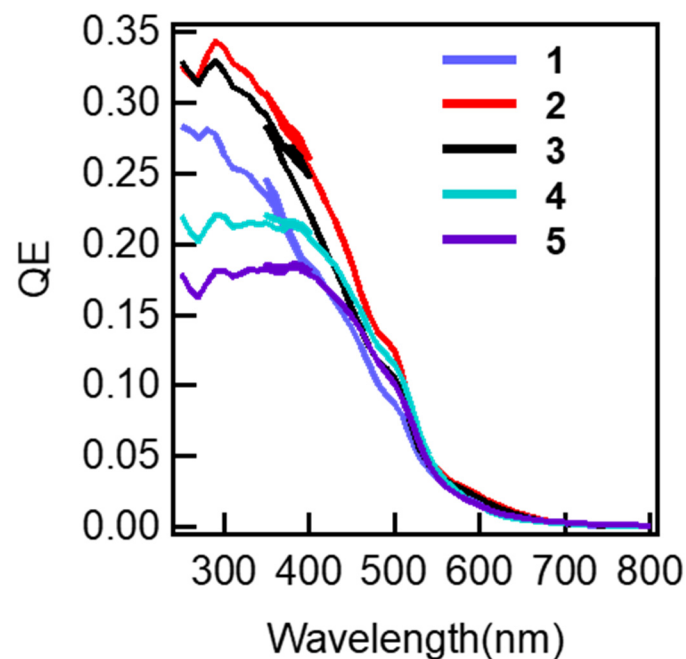
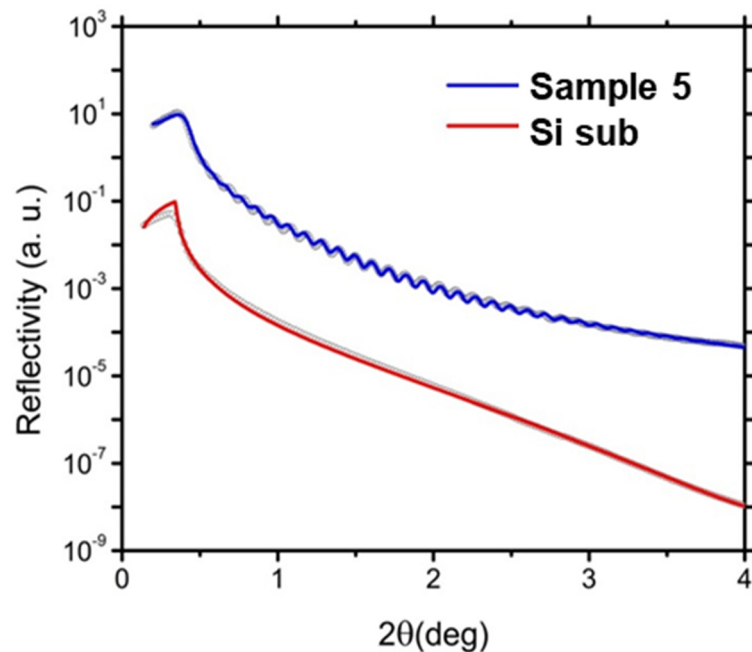


Samples	K	Cs	Sb
1	2.50	1.16	1.00
2	2.37	0.91	1.00
3	2.21	0.95	1.00
4	2.07	0.94	1.00
5	1.98	0.88	1.00
mean	2.23	0.97	1.00



- ☐ Good K-Cs-Sb ratio
- ☐ Highly textured K_2CsSb phase
- ☐ Large crystal grain

TC Method: sample analyses



QE @ 532 nm (%)	R (Å)	d (Å)	Grain size (nm)
5.8	11.5	815.3	27.7

□ High QE and Smooth Surface

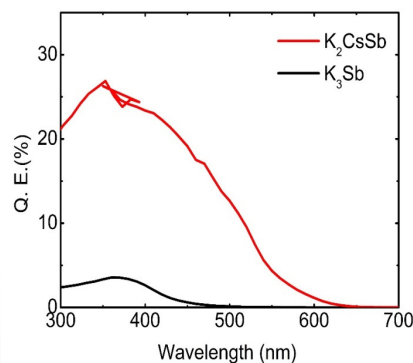
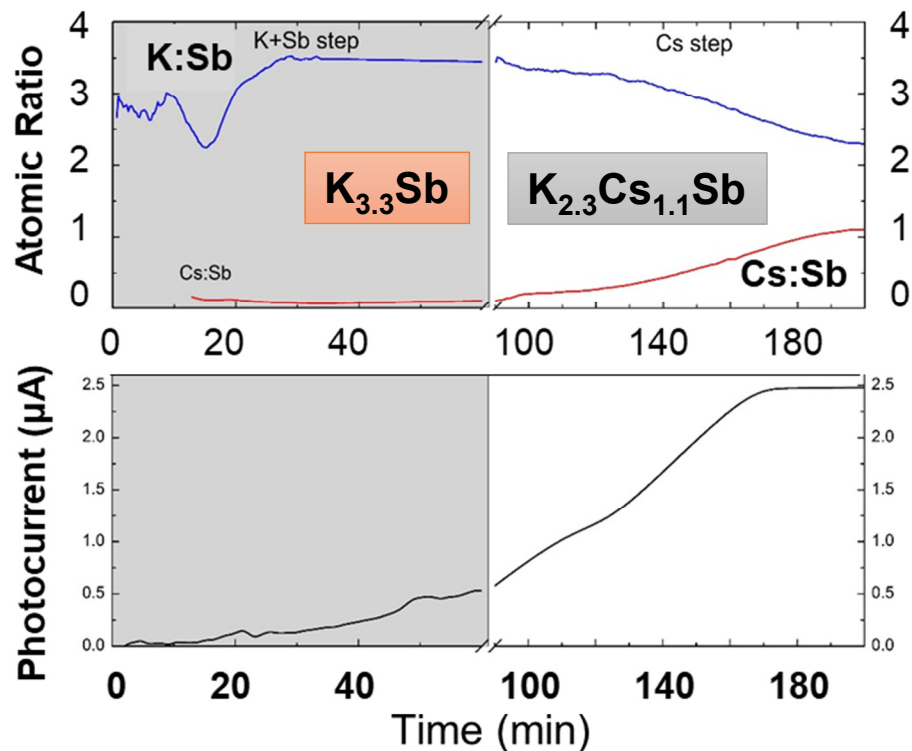
Two-step Method:

Two-step Evaporation

K, Sb co-deposition @ 120°C to maximize QE @ 380 nm

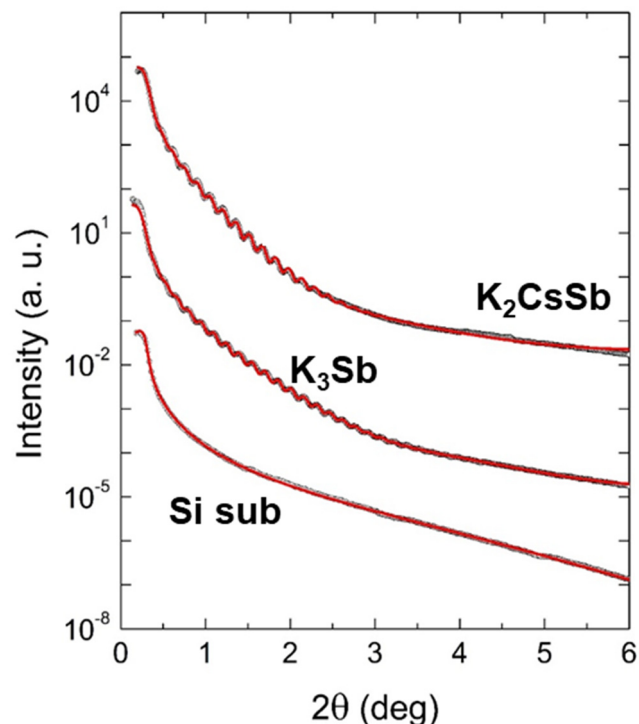
Cs deposition @ 100°C to maximize QE @ 532°C

- ☐ Simply monitor the **QE**
- ☐ No need monitoring stoichiometry
- ☐ Convenient
- ☐ Comparative QE

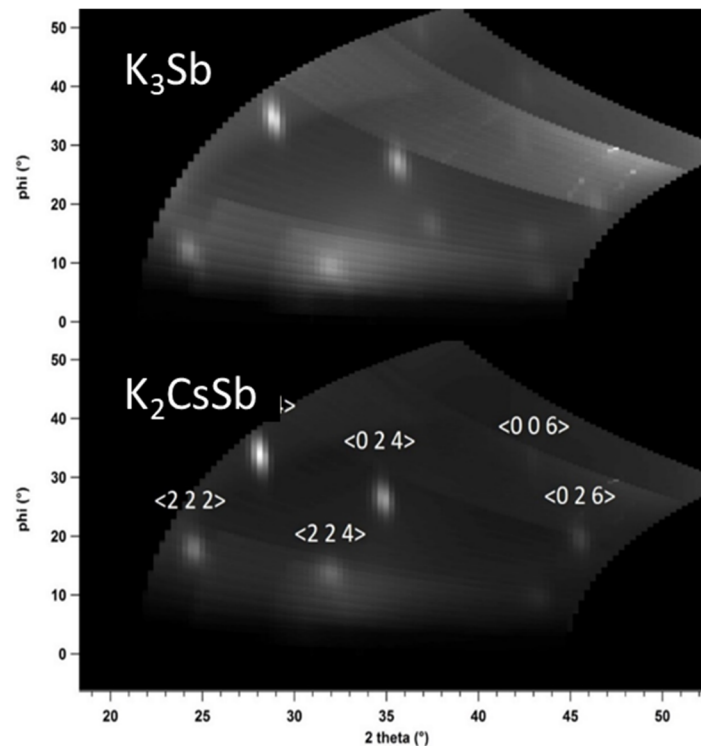


- ☐ QE after sufficient Cesiumation:
- ☐ **26% @ 360 nm**
- ☐ **7% @ 530 nm**

Two-step Method: XRR and XRD



	d (nm)	R (Å)
K_2CsSb	38.8	10.0
K_3Sb	39.3	8.3
Si sub	-	2.4



- ☐ Sub-nm roughness
- ☐ Textured XRD pattern
- ☐ Hexagonal $K_3Sb \rightarrow$ cubic K_2CsSb

Summary:

Ternary co-dep vs. Two-step

Method	d (nm)	R (Å)	QE @ 360 nm	QE @ 532 nm
Triple Evaporation	81	11.5	27%	5.8%
Two-step	39	10.0	26%	7.0%

Both methods:

- ☐ High QE
- ☐ Smooth surface
- ☐ Well crystallized

Triple Evaporation:

- Requires thicker thin film
- Critical crystallization
- Maintains stoichiometry

Two-step:

- Flexible
- Monitoring QE

Acknowledgement



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